

L Number	Hits	Search Text	DB	Time stamp
-	1	Fujitugu-Hideki.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:07
-	153	(Ushiodenki adj Kabushiki adj Kaisha).as.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:08
-	9	((Ushiodenki adj Kabushiki adj Kaisha).as.) and (dielectric near discharge)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:48
-	84	((Ushiodenki adj Kabushiki adj Kaisha).as.) and (discharge near lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:24
-	15	((Ushiodenki adj Kabushiki adj Kaisha).as.) and (discharge near lamp)) and ((surface substrate workpiece sample) near (treat\$4 irradiat\$3 illumimnat\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:20
-	4	((Ushiodenki adj Kabushiki adj Kaisha).as.) and (discharge near lamp)) and (light near (screen\$3 filter\$3 cover\$3 block\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:23
-	556	250/453.11.ccls. 250/454.11.ccls. 250/455.11.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:24
-	8	(250/453.11.ccls. 250/454.11.ccls. 250/455.11.ccls.) and (discharge near lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:52
-	3932	250/492.1.ccls. 250/492.2.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:53
-	7	(250/492.1.ccls. 250/492.2.ccls.) and (dielectric near barrier near discharge)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:57
-	485	427/582.ccls. 313/507.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:57
-	2	(427/582.ccls. 313/507.ccls.) and (dielectric near barrier near discharge)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 14:58
-	39	315/\$.ccls. and (dielectric near barrier near discharge)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 15:03
-	777	dielectric near barrier near discharge	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 18:07
-	501	(dielectric near barrier near discharge) and (substrate workpiece sample wafer semiconductor surface)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 15:10
-	43	(dielectric near barrier near discharge) and (light near2 (screen\$3 block\$3 filter\$3 cover\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 15:57
-	41	((dielectric near barrier near discharge) and (substrate workpiece sample wafer semiconductor surface)) and ((dielectric near barrier near discharge) and (light near2 (screen\$3 block\$3 filter\$3 cover\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 15:58

-	50	(dielectric near barrier near discharge) and overlap\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 15:58
-	2	(dielectric near barrier near discharge) and (light near shield)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 18:16
-	2	5510158.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 18:40
-	2	4983881.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/19 18:40
-	4	("4266167" "4778581" "4837484" "4851734").PN.	USPAT	2003/05/19 18:40
-	26	4983881.URPN.	USPAT	2003/05/19 18:41
-	7	("4876689" "4983881" "5119262" "5886480" "5977722" "6087776" "6229721").PN.	USPAT	2003/05/19 18:42
-	0	6495972.URPN.	USPAT	2003/05/19 18:42
-	5019	(light with (cover screen\$3 block\$3 shield\$3)) same overlap\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 09:35
-	57	((light with (cover screen\$3 block\$3 shield\$3)) same overlap\$4) and (discharge near lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 10:17
-	407	dielectric adj barrier adj discharge adj lamp	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 10:18
-	72	(dielectric adj barrier adj discharge adj lamp) and ((shield\$3 cover\$3 block\$3) same lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 12:22
-	12	((dielectric adj barrier adj discharge adj lamp) and ((shield\$3 cover\$3 block\$3) same lamp)) and overlap\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 14:54
-	57756	(screen\$3 shield\$3 block\$3) with window	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 12:22
-	4	((screen\$3 shield\$3 block\$3) with window) and (dielectric adj barrier adj discharge adj lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 12:24
-	152	dielectric adj barrier adj discharge adj lamp	JPO	2003/05/20 15:09
-	2	(dielectric adj barrier adj discharge adj lamp) and overlap\$4	JPO	2003/05/20 14:56
-	3	(dielectric adj barrier adj discharge adj lamp) and ((transport\$3 mov\$3 slid\$3) near (substrate wafer workpiece))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/20 15:12
-	6658	light same (screen shield) same window	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 12:50
-	94	(light same (screen shield) same window) and (discharge near lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 13:10
-	2	(light same (screen shield) same window) and (dielectric near barrier near discharge near lamp)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 12:56

-	0	"screen in window"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 13:11
-	0	"shield in window"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 13:31
-	0	"plate in window"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/05/21 13:33

WEST[Help](#)[Logout](#)[Interrupt](#)[Main Menu](#)[Search Form](#)[Posting Counts](#)[Show S Numbers](#)[Edit S Numbers](#)[Preferences](#)[Cases](#)**Search Results -**

Terms	Documents
(Dielectric adj Barrier adj Discharge adj Lamp adj Device).ti.	25

Database:

US Patents Full-Text Database
US Pre-Grant Publication Full-Text Database
JPO Abstracts Database
EPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search:

L1

[Refine Search](#)[Recall Text](#)[Clear](#)**Search History****DATE:** Wednesday, May 21, 2003 [Printable Copy](#) [Create Case](#)**Set Name Query**

side by side

Hit Count Set Name

result set

*DB=USPT,PGPB,JPAB,EPAB,DWPI; PLUR=YES; OP=OR*L1 (Dielectric adj Barrier adj Discharge adj Lamp adj Device).ti.

25

L1

END OF SEARCH HISTORY